

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan

Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING

Docket No.: 303.928US5

Serial No.: 09/652,713

Filed: August 31, 2000

Due Date: June 19, 2007

Examiner: Sylvia MacArthur

Group Art Unit: 1763

MS Appeal Brief - Patents

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Appeal Brief Under 37 CFR 41.37, including Appendices, Copies of Related Decisions on Appeal and Table of Contents (36 pgs.).
- ☒ Authorization to charge Deposit Account No. 19-0743 in the amount of \$500 for Appeal Brief Fee..

If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: 

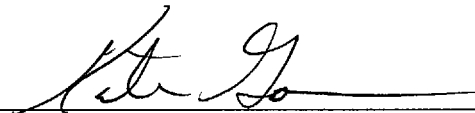
Atty: Timothy B. Clise

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 18 day of June, 2007.



Name



Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)